KAJIHARA LAB.

[Manufacturing and THz microscopy]

Department of Mechanical and Biofunctional Systems

http://www.snom.u-tokyo.ac.jp/

Manufacturing Science Fundamentals

Department of precision engineering

Novel THz measurement

Visualizing local phenomena on material's surface

Terahertz wave (wavelength: 10 μ m ~ 50 μ m) contains many important spectra of matters due to molecular vibration, lattice phonon, and biomolecular motion. We are developing a near-field microscope, which "passively (without external illumination)" detects spontaneous THz photons originated from localized phenomena at "nanoscale" resolution. We are also developing a new jointing manufacturing technique.

Passive THz near-field microscopy without external illumination (spatial resolution = 60 nm) Non-destructive THz nano-thermometry Product evaluation based on THz photoelastic method

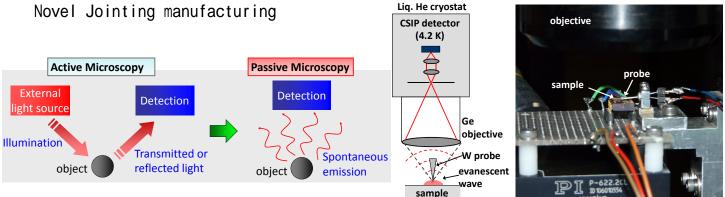
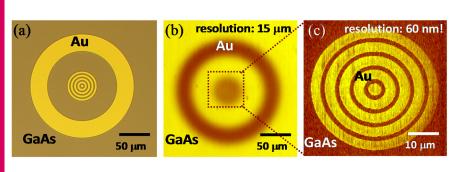
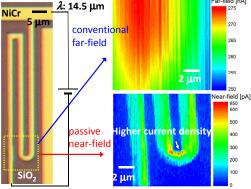


Fig.1 Conventional active measurement and our passive measurement

Fig. 2 Passive THz near-field microscope





field [nA]

Fig.3 (a) Microscope image (b) Passive far-field image (c) Passive near-field image

Fig. 4 Current density distribution mapped with THz nano-thermometry